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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Unknown

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING

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SECOND REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents
Office of Initial Patent Examination
Customer Service Center
Washington, D.C. 20231

Sir:

We enclose a copy of the Corrected Official Filing Receipt, as well as the first Request for Corrected Official Filing Receipt, for the above-identified application and request the following correction:

IN THE TITLE: delete "fro" and insert therefor --for--.

Verification for the requested correction is indicated on the first Request for Corrected Official Filing Receipt filed April 19, 2001, as well as the original Declaration and Power of Attorney filed February 20, 2001.

Respectfully submitted,

Christopher R. Lipp
Registration No. 41,157

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Date: December 5, 2001

Attorney Docket No.: Q63075



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
 UNITED STATES PATENT AND TRADEMARK OFFICE
 WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/763,194	02/20/2001	1725	1020	Q63075	8	13	5



Sughrue Mion Zinn
 Macpeak & Seas
 2100 Pennsylvania Avenue NW
 Washington, DC 20037

CONFIRMATION NO. 3832
 CORRECTED FILING RECEIPT



OC000000007052980

Date Mailed: 11/09/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kazunobu Fujikawa, Tokyo, JAPAN;
 Akihiro Goto, Tokyo, JAPAN;

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Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP99/02379 05/07/1999

Foreign Applications

If Required, Foreign Filing License Granted 03/21/2001

Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

Title

Method and apparatus for surface discharge processing, and an electrode [for] surface discharge processing

Preliminary Class

219

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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In re application of

KAZUNOBU FUJIKAWA, et al.

Appln. No. 09/763,194

Group Art Unit: 1725

Confirmation No.: Not yet assigned

Examiner: Not yet assigned

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING

PAPER(S) FILED ENTITLED:

1. Request For Corrected Official Filing Receipt, with copy of marked-up Official Filing Receipt
2. copy of Declaration and Power of Attorney

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FILED

APR 19 2001

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction(s):

TITLE: delete "METHOD AND APPARATUS FOR SURFACE TREATMENT BY ELECTRODISCHARGING, AND DISCHARGE ELECTRODE" and insert --METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING--

Verification for the requested correction(s) is indicated on the original Declaration and Power of Attorney filed February 20, 2001.

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